



Attorney Docket No. 0756-7290

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Misako NAKAZAWA et al.

Serial No. 10/822,820

Filed: April 13, 2004

For: CRYSTALLINE SEMICONDUCTOR

FILM, METHOD OF

MANUFACTURING THE SAME, AND

SEMICONDUCTOR DEVICE

) Group Art Unit: 2825

) Examiner: G. Lee

) CERTIFICATE OF MAILING

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AMENDMENT AND RESPONSE TO RESTRICTION REQUIREMENT

Honorable Commissioner of Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

Please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 12 of this paper.

12/03/2004 ZJUHA1 00000066 10822820

01 FC:1202
02 FC:1201

504.00 OP
264.00 OP